

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
STEPHEN KEETAI PARK

Serial No.: 10/045,895

Filed: October 29, 2001

For: METHOD OF FABRICATING  
COPPER-BASED SEMICONDUCTOR  
DEVICES USING A SACRIFICIAL  
DIELECTRIC LAYER

Examiner: Hsien-Ming Lee

Group Art Unit: 2823

Att'y Docket: 2000.029996/TT3586C

RESPONSE TO OFFICE ACTION DATED AUGUST 28, 2003Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450CERTIFICATE OF TRANSMISSION  
37 C.F.R. 1.6(d)I hereby certify that this correspondence is being transmitted to the  
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450,  
703-872-9318 on the date below:

October 02, 2003

Date

  
Kathryn Danae

Sir:

This paper is submitted in response to the Office Action dated August 28, 2003, for which the three-month date for response is November 28, 2003.

It is believed that no fee is due; however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason, the Assistant Commissioner is authorized to deduct said fees from Advanced Micro Devices, Inc.'s Deposit Account 01-0365/TT3658C.

Reconsideration of the application is respectfully requested.

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